

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

In re Application of: John Robert Lamberty *et al.*

Serial Number: 10/711,983

Group Art Unit: 2882

Filing Date: October 18, 2004

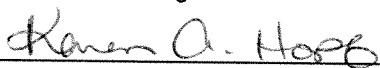
Examiner: Chih-Cheng Glen Kao

For: METHOD AND SYSTEM FOR SCATTER CORRECTION
DURING BI-PLANE IMAGING WITH SIMULTANEOUS EXPOSURE

Attorney Docket Number: GEMS 0169 PUS (125720)

CERTIFICATE OF MAILING/TRANSMISSION

I hereby certify that this correspondence is, on the date shown below, being electronically filed with the United States Patent & Trademark Office via the EFS-Web and a registered e-Filer certificate.


Signature

Date: September 17, 2007

Karen Hopf

**AMENDMENT AND REQUEST FOR RECONSIDERATION
(37 C.F.R. § 1.111 AND § 1.121)**

Commissioner for Patents
Attention: Examiner Chih-Cheng Glen Kao
Mail Stop AMENDMENT
P. O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

To better highlight the patentable differences between the above-referenced invention and prior art that is cited by Examiner in an Office Action marked "non-final" and dated March 15, 2007, Applicants hereby submit this "Amendment and Request for Reconsideration" for their above-referenced Application pursuant to 37 C.F.R. § 1.111 and § 1.121. In submitting this Amendment, Applicants respectfully aver that the Application, as herein amended, is in a condition for allowance and notice thereof is respectfully requested. At the present time, therefore, please amend the Application as hereinafter indicated.